

Amendments to the Specification:

Please amend the Title on page 1 as follows:

SEMICONDUCTOR DEVICE WITH SPIRAL INDUCTOR AND METHOD FOR
FABRICATING SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE

Please replace the paragraph at page 1, lines 5-8, with the following rewritten
paragraph:

This application claims benefit of priority under 35_U.S.C. § 119 to Japanese patent
application No. 2000-295823, filed on September 28, 2000, and from U.S. Application No.
09/960,333, filed September 24, 2001, the contents of which are incorporated by reference
herein.